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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
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EXAMINER

WILSON, ALLAN R

ART UNIT PAPER NUMBER

2815

DATE MAILED: 05/01/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No.

10/759,081

Applicant(s)

LI, CHOU H.

Examiner

Allan R. Wilson

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-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --
Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 16 March 2006.
- 2a) ☒ This action is **FINAL**. 2b) ☐ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) See Continuation Sheet is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1,3,5,6,8,10,15,16,18-20,22-26,28,30-34,36,38,45-50,52-54 and 56-85 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
- ☐ Certified copies of the priority documents have been received.
 - ☐ Certified copies of the priority documents have been received in Application No. _____.
 - ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- ☐ Notice of References Cited (PTO-892)
- ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- ☐ Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)
Paper No(s)/Mail Date _____
- ☐ Interview Summary (PTO-413)
Paper No(s)/Mail Date. _____
- ☐ Notice of Informal Patent Application (PTO-152)
- ☐ Other: _____

Continuation of Disposition of Claims: Claims pending in the application are 1,3,5,6,8,10,15,16,18-20,22-26,28,30-34,36,38,45-50,52-54 and 56-85.

DETAILED ACTION***Double Patenting***

The nonstatutory double patenting rejection is based on a judicially created doctrine grounded in public policy (a policy reflected in the statute) so as to prevent the unjustified or improper timewise extension of the “right to exclude” granted by a patent and to prevent possible harassment by multiple assignees. A nonstatutory obviousness-type double patenting rejection is appropriate where the conflicting claims are not identical, but at least one examined application claim is not patentably distinct from the reference claim(s) because the examined application claim is either anticipated by, or would have been obvious over, the reference claim(s). See, e.g., *In re Berg*, 140 F.3d 1428, 46 USPQ2d 1226 (Fed. Cir. 1998); *In re Goodman*, 11 F.3d 1046, 29 USPQ2d 2010 (Fed. Cir. 1993); *In re Longi*, 759 F.2d 887, 225 USPQ 645 (Fed. Cir. 1985); *In re Van Ornum*, 686 F.2d 937, 214 USPQ 761 (CCPA 1982); *In re Vogel*, 422 F.2d 438, 164 USPQ 619 (CCPA 1970); and *In re Thorington*, 418 F.2d 528, 163 USPQ 644 (CCPA 1969).

A timely filed terminal disclaimer in compliance with 37 CFR 1.321(c) or 1.321(d) may be used to overcome an actual or provisional rejection based on a nonstatutory double patenting ground provided the conflicting application or patent either is shown to be commonly owned with this application, or claims an invention made as a result of activities undertaken within the scope of a joint research agreement.

Effective January 1, 1994, a registered attorney or agent of record may sign a terminal disclaimer. A terminal disclaimer signed by the assignee must fully comply with 37 CFR 3.73(b).

Claims 1, 3, 5, 6, 8, 10, 15, 16, 18-20, 22-26, 28, 30-34, 36, 38, 45-50, 52-54 and 56-85 are provisionally rejected on the ground of nonstatutory obviousness-type double patenting as being unpatentable over claims 44-53 of copending Application No. 08/483,938. Although the conflicting claims are not identical, they are not patentably distinct from each other because, for example, the present application’s claim 1 is broader than claim 44 of the ‘938 patent. The present application’s claim 1 contains the same limitations as claim 44 of the ‘938 patent except “the barrier region having a selected surface which is microscopically precise, better than one micron in accuracy in shape size, and position or the rectifying barrier; on a vertical cross-

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section, said barrier region having a curved portion in a major central portion thereof” which can be added to the open claim 1.

This is a provisional obviousness-type double patenting rejection because the conflicting claims have not in fact been patented.

Specification

The specification is objected to as failing to provide proper antecedent basis for the claimed subject matter. See 37 CFR 1.75(d)(1) and MPEP § 608.01(o). Correction of the following is required: Claim 20 recites “a terminal portion” in line 17. There is insufficient antecedent basis for this limitation in the specification.

Claim Rejections - 35 USC § 112

The following is a quotation of the second paragraph of 35 U.S.C. § 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

Claims 3, 5, 20, 22-26, 28, 30-34, 36, 38 and 75 are rejected under 35 USC § 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention. The structure which goes to make up the device must be clearly and positively specified. The structure must be organized and correlated in such a manner as to present a complete operative device.

Claims 3 and 20, the phrase “accuracy of a few hundred atomic layers” is indefinite. The size of the dimension is unclear.

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Claims 22-26, 28, 30-34, 36 and 38 are rejected as being depended on rejected claims 20 and 57.

Claim 75 has numerous relative terms which renders the claim indefinite. For example, the terms “precise,” “sever,” “high,” and “large” are not quantified. The terms are not defined by the claim, the specification does not provide a standard for ascertaining the requisite degree, and one of ordinary skill in the art would not be reasonably apprised of the scope of the invention. These terms render limitations, e.g., amount of thermal mismatch, density, or size of electrical contacts indefinite.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

Claims 1, 3, 5, 6, 8, 10, 18-20, 22-26, 28, 30-32, 34, 36, 38, 45, 46, 48-50, 56-58, 60, 63, 65, 67, 72, 73 and 75-77 are rejected under 35 USC § 103 (a) as being unpatentable over U.S. Patent No. 4,916,716 to Fenner et al. (“Fenner”) in view of U.S. Patent No. 3,341,754 to Keller et al. (“Keller”).

With regards to claims 1 and 75, Fenner illustrates in figures 1 and 2 (entire document) a solid substrate 2, 3 of one conductivity type n; a solid material pocket 4 of a different conductivity type p having a side surface and positioned on a selected top surface of said

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substrate; signal-translating, electronic rectifying barrier 3/4 located between said solid material pocket and the selected top surface of said substrate; and a solid state material region 7 adjoining said solid substrate, said electronic rectifying barrier, and the side surface of said solid material pocket.

Fenner does not show “a said solid state material region having a depth accuracy of better than 0.13 microns; and being continuously and perfectly bonded metallurgically to all said solid substrate, said solid material pocket, and said rectifying barrier, without the almost always present thermally and electrically insulating voids and microcracks visible at 1,000 times magnification in interfacial bonding regions between the bonded device components” Keller discloses in col. 3, lines 20-25, “the edge of the region may be controlled with great accuracy down to some few hundred atomic layers” it would be obvious the control of the depth accuracy would be better than 0.13 microns. It would have been obvious to one of ordinary skill in the art at the time the invention was made to have a accuracy of better than 0.13 microns. The motivation for doing this is to meet the device design needs.

Since the claimed material and structure limitation are met by Fenner, the limitation relating to the insulating voids and microcracks of the layers are also met as a natural result. Fenner discloses in col. 2, lines 65-68, solid state material region 7 (channel or guard ring) is produced by ion implantation of oxygen. This is the same material and process used by Applicant..

With regards to claims 3 and 30, Keller discloses in col. 3, lines 20-25, at least “the edge of the region may be controlled with great accuracy down to some few hundred atomic layers.”

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With regards to claims 5 and 6, Fenner illustrates in FIG. 1 a selected significant portion of a major surface of said solid state material region 7 gradually changes a vertical thickness thereof with closeness in a lateral direction to a lateral edge of said electronic rectifying barrier 3/4.

With regards to claims 8 and 10, Fenner illustrates in FIG. 1 at: least a major surface said solid material pocket 7 is curved over a major portion thereof.

With regard to claim 18, Fenner illustrates in FIG. 1 and discloses in col. 2, lines 57-60, layer 3 has a thickness of 0.2 to 2 microns, a laterally-extending dimension of less than one micron is obvious.

With regards to claims 19, 28, 38 and 58, Fenner discloses said solid state material region 7 consists essentially of oxide, metal and electrically insulating solid (Fenner col. 2, lines 65-68); said electronic rectifying barrier 3/4 is selected from the group consisting of a PN junction and a Schottky barrier; and said solid material pocket is GaAs.

With regards to claim 20, Fenner illustrates in FIG. 1 a first semiconductor material body 4 having a first polarity "p"; a second semiconductor material body 3 located generally vertically underneath said first semiconductor material body and having a second polarity "n" that is opposite the first polarity; a signal-translating, electronic rectifying barrier 3/4 formed between said first and second semiconductor material bodies; and a third solid state material body 7 having an electrical conductivity at least one order of magnitude different from those of said first and second semiconductor material bodies (inherent); said third solid state material body contacting respective portions of each of said first and second semiconductor material bodies and said electronic rectifying barrier, and having two differentially surface-expanded sides that are

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not parallel to each other to form a terminal portion of no more than a micron in thickness in a selected direction; and said thickness being accurate to within a few hundred atomic layers (see claim 3 above).

With regards to claim 22, Fenner discloses in col. 2, lines 57-59, said second semiconductor material body 3 is of an intrinsic semiconductor material (weakly n-conductive).

With regards to claim 23, Fenner discloses in col. 2, lines 65-68, said third solid state material body 7 has an as-formed metallurgically graded-seal continuity of a graded-seal type with respect to at least one of said first 4 and second 3 semiconductor material bodies (see claim 3 above).

With regards to claims 24 and 56, Fenner discloses in col. 2, lines 57-60, the terminal portion of said third solid state material body 7 is vertically within less than a distance from a selected point inside said electronic rectifying barrier; said distance being one micron since the thickness of layer 3 can be as thin as 0.2 μm .

With regards to claim 25, since Fenner illustrates in FIG. 1 the third solid state material body 7 has the same geometry, position, and orientation relative to said first 4 and second 3 semiconductor material bodies, it will allow adequate stress and strain modification on said electronic rectifying barrier thereby improving device performance.

With regards to claim 26, Fenner illustrates in FIG. 1 said third solid state material body 7 is favorably stressed, and has a blunt and rounded bottom of zero width and a the rounded bottom of said third solid state material body is located within one micron from a designated point inside said electronic rectifying barrier (see claim 24).

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With regards to claim 31, Fenner illustrates in FIG. 1 said third solid state material body 7 has a rounded portion forming an inverted arch.

With regards to claim 32, Fenner illustrates in FIG. 1 the terminal portion of said third solid state material body is zero in the lateral direction.

With regards to claim 34, Fenner illustrates in FIG. 2 said third solid state material body 7 has a cylindrical surface.

With regards to claim 36, the limitation “said electronic rectifying barrier is stressed to improve a performance of said semiconductor device” is an inherent function of the structure and since the prior art has the same structure and materials as the claimed invention it will have the same inherent function.

With regards to claim 45, Fenner illustrates in FIG. 1 said electronic rectifying barrier 3, 4 adjoins both said solid substrate 3 and said solid state material region 7 at a place where a periphery of said electronic rectifying barrier is differentially surface-expanded.

With regards to claim 46, Fenner illustrates in FIG. 1 said solid state material region is size with an accuracy of less than 0.13 microns (see claim 3), and having a bottom of a shape selected from the group consisting of rounded, cylindrical or hemispherical.

With regards to claims 48, 49 and 50, Fenner illustrates in FIG. 1 said electronic rectifying barrier 3, 4 has a lateral edge, and said solid state material region 7 has a portion thereof which gradually and continuously changes its vertical thickness with closeness to said lateral edge of said electronic rectifying barrier.

With regards to claim 57, Fenner illustrates in FIG. 1 a first solid state material 4 of a first conductivity type “p”, a second solid state material 3 of a second conductivity type positioned

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under the first solid state material, the first and second solid state materials having respective adjoining portions; a signal-translating, rectifying barrier region 3/4 lying between the respective adjoining portions; and a device material region 7 starting at least in the first solid state material and extending toward the rectifying barrier region to form a bottom which is within a micron (see claim 24) of a selected point inside the rectifying barrier region; a major portion of a top surface area of device chip being occupied by device circuit elements themselves thereby achieving hitherto impossible, device miniaturization.

With regards to claim 60, Fenner illustrates in FIG. 1 the device material region 7 is an elongated device material region; is accurate to less than a micron (see claim 3) in a dimension selected from the group consisting of shape, size, depth, and chemical composition profiling; and consists essentially of a device material selected from the group consisting essentially of oxide, metal, other electrically insulating material (Fenner col. 2, lines 65-68).

Regarding claim 63, Fenner illustrates in FIG. 1 only a minor portion of a top surface area of device chip is not occupied by device circuit elements themselves; said device circuit elements having no centrally large and flat bottoms as in oxidized isolation bottoms of Peltzer and Murphy devices, thereby achieving radically improved device miniaturization.

With regards to claim 65, Fenner illustrates in FIG. 1 and discloses in col. 2, lines 57-60, the device material region 7 is an elongated and layer 3 has a thickness of 0.2 to 2 microns, cylindrical device material groove having both an aspect ratio of over 3 to 5 (inherent) and a cylindrical radius of less than one micron, and is oriented generally normally of a top surface of the second solid state material 3.

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With regards to claim 67, Fenner illustrates in FIG. 1 and discloses in col. 2, lines 57-60, the device material region 7 is an elongated and layer 3 has a thickness of 0.2 to 2 microns, the cylindrical radius of less than one micron is obvious.

With regards to claim 72, Applicant is reminded that intended functional use is given no patentable weight in claims drawn to structure. See *In re Pearson* 181 USPQ 641 and *Ex parte Minks* 169 USPQ 120.

Regarding claim 73, Fenner illustrates in FIG. 1 the device material region 7 is a vertical and electrically insulating, elongated device material groove; and a lower end of the vertical, elongated groove has a centrally rounded bottom of substantially zero width in a direction parallel to a top major surface of the second solid state material.

Regarding claims 76 and 77, Fenner illustrates in FIG. 1 a top surface of said solid substrate 2 contacts a non-flat surface of material region 7 and having a round surface.

With regard to claim 85, a change in size (if any) is generally recognized as being within the level of ordinary skill in the art. MPEP § 2144.04 IV.

Response to Arguments

Applicant's arguments with respect to the claims have been considered but are moot in view of the new ground(s) of rejection.

The objection to the specification has not been obviated in view of the amendment.

The 35 USC § 112 rejection of claims 3, 5, 20, 23-26, 28, 30-34, 36 and 38 has not been obviated in view of the amendment.

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Due to the amendment (e.g. addition of new claims), rejection has been changed to a 35 USC § 103 to make the rejection more compact, though the Examiner believes most of the limitations are inherent.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a).

Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from an examiner should be directed to Primary Examiner Allan Wilson whose telephone number is (571) 272-1738. Examiner Wilson can normally be reached 6:00-4:30 Tuesday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Ken Parker can be reached on (571) 272-2298. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

A handwritten signature in black ink, appearing to read "A. Wilson", with a stylized, flowing script.

Allan R. Wilson
Primary Examiner
20 April 2006